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CONFIRMATION NO. 4799

SERIAL NUMBER 10/689,617	FILING DATE 10/22/2003  RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 12732-170001	
<b>APPLICANTS</b>  Satoru Okamoto, Isehara, JAPAN;  ** CONTINUING DATA *****  ** FOREIGN APPLICATIONS ***** JAPAN 2002-310257 10/24/2002  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/17/2004					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature _____ Initials _____	STATE OR  COUNTRY JAPAN	SHEETS  DRAWING 9	TOTAL  CLAIMS 95	INDEPENDENT  CLAIMS 13
<b>ADDRESS</b> 26171 FISH & RICHARDSON P.C. P.O. BOX 1022 MINNEAPOLIS , MN 55440-1022					
<b>TITLE</b> Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device					
FILING FEE  RECEIVED 2980	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )		